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Bib Data Sheet

CONFIRMATION NO. 4559

SERIAL NUMBER 10/069,943	FILING DATE 07/10/2002  RULE	CLASS 501	GROUP ART UNIT 1755	ATTORNEY DOCKET NO. 219289USOPCT
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP00/03041 05/12/2000

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 11-251842 06/09/1999

JAPAN 11-251843 06/09/1999

JAPAN 11-355550 12/15/1999

JAPAN 11-355551 12/15/1999

JAPAN 11-360612 12/20/1999

JAPAN 11-360613 12/20/1999

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 36	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature  Initials				

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## TITLE

Carbon-containing aluminium nitride sintered compact and ceramic substrate for use in equipment for manufacturing or inspecting semiconductor

☐ All Fees☐ 1.16 Fees ( Filing )